



1732

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

**Brian W. Baird, Michael J. Wolfe,
Richard S. Harris, Kevin P. Fahey,
Lian-Cheng Zou, and Thomas R. McNeil**

Confirmation No. 1732

Application No. 10/017,497

Filed: December 14, 2001

For: **ULTRAVIOLET LASER ABLATIVE
PATTERNING OF MICROSTRUCTURES
IN SEMICONDUCTORS**

Examiner: Dr. Stefan Staicovici

Date: June 9, 2005

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TO THE COMMISSIONER FOR PATENTS:

Enclosed for filing in the above-referenced application are the following:

- ☒ Amendment B
- ☒ Patent Application Fee Determination Record
- ☒ Return Receipt Postcard

The Commissioner is hereby authorized to charge any additional fees which may be required in connection with filing of these papers, or credit overpayment, to Account No. 19-4455.

Respectfully submitted,

**Brian W. Baird, Michael J. Wolfe,
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